



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Patent Application of: Wen-Song Tseng, et al.

Serial No.: 10/761,002

Group Art Unit: 1634

Filed: January 20, 2004

Examiner: F. Toledo

For: **WET BENCH WAFER FLOATING DETECTION SYSTEM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE**

<p><b>CERTIFICATE OF MAILING,</b> 37 C.F.R. §1.8(a)</p> <p>I certify that this correspondence and the enclosures mentioned therein are being deposited by First Class U.S. Mail with sufficient postage on the date shown below, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p> <p><i>Richard A. Paikoff</i> Richard A. Paikoff, Reg. No. 34,892</p> <p><u>3/27/06</u> Date</p>
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Sir:

In response to the Office Action of December 28, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.